

PROCEEDINGS OF SPIE

High Contrast Metastructures XIV

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Editors

27–30 January 2025

San Francisco, California, United States

Sponsored and Published by
SPIE

Volume 13378

Proceedings of SPIE 0277-786X, V. 13378

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Author(s), "Title of Paper," in *High Contrast Metastructures XIV*, edited by Connie J. Chang-Hasnain, Andrea Alù, Weimin Zhou, Proc. of SPIE 13378, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510685048

ISBN: 9781510685055 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time)

SPIE.org

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